



Docket No. 0756-2077

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10-1601
TO 2800 MAIL ROOM

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT application of:)
Shunpei YAMAZAKI et al.) Art Unit: 2818
Serial No. 09/466,828) Examiner: R. Berry
Filed: 12/20/1999)
For: INSULATING FILM AND METHOD OF) Date: September 7, 2001
PRODUCING SEMICONDUCTOR DEVICE)

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Assistant Commissioner for Patents, Washington, D.C. 20231, on 2001.

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
Washington, D.C. 20231

Sir:

In accordance with the provisions of 37 C.F.R. 1.56 and 37 C.F.R. 1.97-1.99, it is requested that the reference(s) listed on the attached Form PTO-1449 be made of record in the above-identified application. Copies of the references are submitted herewith in accordance with 37 C.F.R. 1.98(a).

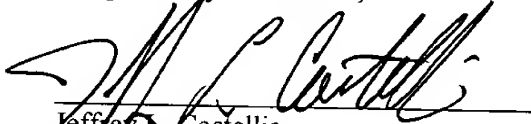
JP 07-074245 was cited in a corresponding Japanese application. US 5,429,995 and US 5,641,581 corresponds to JP 07-074245. The *Van der Muelen et al.* article was submitted in a corresponding Japanese application.

In a corresponding Japanese Patent Application the Examiner cited JP 07-07425 in an Office Action. Specifically, the Examiner in Japan asserted that the JP7-74245 reference, allegedly discloses that a silicon oxide film formed through a plasma CVD using TEOS includes fluorine at a concentration of 1 at % or more and because a density of SiO_2 is $2.2 \times 10^{22} \text{ atm/cm}^3$, 1% of that is $2.2 \times 10^{20} \text{ atm/cm}^3$, which partially coincides with the concentration of the present invention. Further, the Van der Muelen article was submitted in the Japanese application to explain the invention.

Match and R t

The Commissioner is hereby authorized to charge fees under 37 C.F.R. §§1.16, 1.17, 1.20(a), 1.20(b), 1.20(c), and 1.20(d) (except the Issue Fee) which may be required now or hereafter, or credit any overpayment to Deposit Account No. 19-2380. A duplicate copy of this sheet is attached.

Respectfully submitted,



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